

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 24, 2025

IGI Report Number

LG750595034

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

8.56 X 6.11 X 4.15 MM

GRADING RESULTS

Carat Weight

2.10 CARATS

Color Grade

E

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

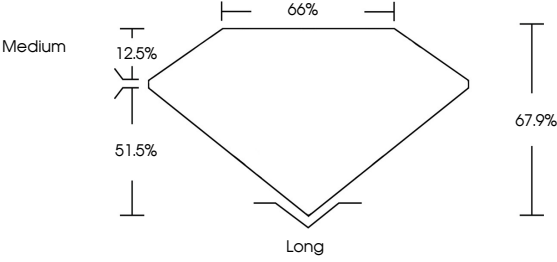
Inscription(s)

 LG750595034

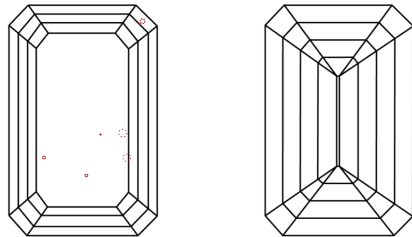
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR


D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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
Symmetry

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Fluorescence

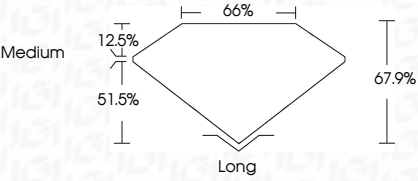
NONE



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PROPORTIONS





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IGI

November 24, 2025

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EMERALD CUT

8.56 X 6.11 X 4.15 MM

2.10 CARATS

E

Color Grade

VS 2

Depth

51.5%

Table

66%

Girdle

Medium

Culet

Long

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

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